



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG784633419
Report verification at igi.org

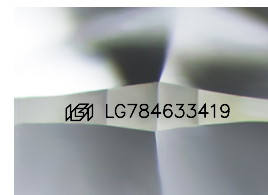
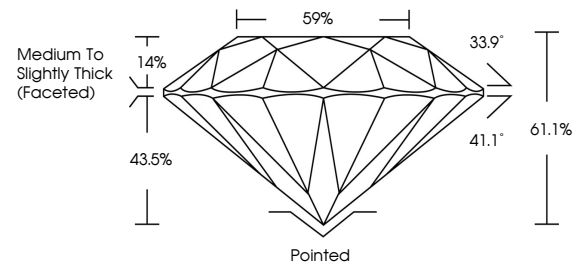
March 18, 2026	
IGI Report Number	LG784633419
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.49 - 7.51 X 4.58 MM
GRADING RESULTS	
Carat Weight	1.58 CARAT
Color Grade	D
Clarity Grade	VS 1
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG74633419

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

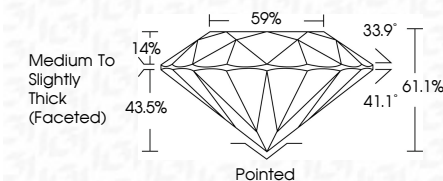
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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March 18, 2026
IGI Report No LG784633419
ROUND BRILLIANT

7.49 - 7.51 X 4.58 MM	Carat Weight	1.58 CARAT
	Color Grade	D
	Clarity Grade	VS 1
	Cut Grade	IDEAL
	Depth	61.1%
	Table	59%
	Girdle	Medium to Slightly Thick (Faceted=0)
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Fluorescence	dom 1 CTR 46.03412

Comments:
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